Electronic Patent Application Fee Transmittal							
Application Number:	10623757						
Filing Date:	21-Jul-2003						
Title of Invention:	Maintaining a reactor chamber of a chemical vapor deposition system						
First Named Inventor/Applicant Name:	Jin Zhao						
Filer:	Timothy M. Hsieh/Barbara Fisher/srj						
Attorney Docket Number:	TI-35855						
Filed as Large Entity							
Utility under 35 USC 111(a) Filing Fees							
Description		Fee Code	Quantity	Amount	Sub-Total in USD(\$)		
Basic Filing:							
Pages:							
Claims:							
Miscellaneous-Filing:							
Petition:							
Patent-Appeals-and-Interference:							
Post-Allowance-and-Post-Issuance:							
Extension-of-Time:							

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Request for continued examination	1801	1	810	810
	Tot	810		